OK. . . to enter BT

Response under 37 C.F.R. § 1.116 Expedited Procedure Examining Group 1765

PATENT ATTORNEY DOCKET NO. 041501-5415

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Il Gweon KIM

Application No.: 09/987,738

Filed: November 15, 2001

For: METHOD FOR FORMING SILICON QUANTUM DOTS AND METHOD FOR FABRICATING NONVOLATILE

MEMORY DEVICE USING THE SAME

Commissioner for Patents
U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, Mail Stop AF
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

AMENDMENT UNDER 37 C.F.R. § 1.116

In response to the Final Office Action dated September 23, 2003 (Paper No. 6), the period for response to which extends through December 23, 2003, entry of the following amendments is respectfully requested to place the application in clear condition for allowance or, alternatively, in better form for appeal.